



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
Address: COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, Virginia 22313-1450
www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 9488

SERIAL NUMBER 10/677,309	FILING DATE 10/03/2003 RULE ✓	CLASS 216	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 243579US0X
-----------------------------	-------------------------------------	--------------	------------------------	-----------------------------------

APPLICANTS

Tetsuo Suzuki, Kobe-shi, JAPAN;

Satoru Takada, Hayward, CA;

** CONTINUING DATA *****

NONE *note*

** FOREIGN APPLICATIONS *****

NONE *note*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 04/28/2004

Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY JAPAN ✓	SHEETS DRAWING 6 ✓	TOTAL CLAIMS 13 ✓	INDEPENDENT CLAIMS 1 ✓
35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>Maureen H. Jones</i> Initials <i>MT</i>				

ADDRESS

22850
OBLON, SPIVAK, MCCLELLAND, MAIER & NEUSTADT, P.C.
1940 DUKE STREET
ALEXANDRIA, VA
22314

TITLE

Method of reclaiming silicon wafers

FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
-------------------------------	---	---